



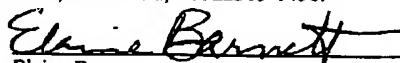
Docket No. COS-867

AF

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Daumerie, et al. §  
Serial No.: 10/044,759 § Group Art Unit: 1713  
Confirmation No.: 8362 §  
Filed: January 9, 2002 § Examiner: Cheung  
For: Method of Removing Volatiles from §  
a Block Copolymer §  
§

MAIL STOP AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

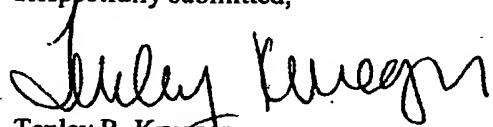
**CERTIFICATE MAILING**  
I hereby certify that the papers herein are being deposited with the  
United States Postal Service as "First Class Mail" in an envelope  
addressed to: Mail Stop AF, Commissioner for Patents, P.O. Box  
1450, Alexandria, VA 22313-1450.  
  
Elaine Barnett November 30, 2004

**NOTICE OF APPEAL FROM THE PATENT EXAMINER TO THE BOARD OF  
PATENT APPEALS AND INTERFERENCES**

The applicants hereby appeal to the Board from the decision of the Patent Examiner mailed November 17, 2004, finally rejecting Claims 1-19. This application is not on behalf of a small entity. Pursuant to 37 CFR 1.17(e) the fee for filing the Notice of Appeal is \$340.00

The Commissioner is hereby authorized to charge the fee of \$340.00 or any  
Adjustment date: additional fees which may be required or credit any overpayment to Deposit Account No.  
12/16/2004 TCOLE1 00000007 033345 10044759  
01 FC:2401 03 170.00 CR

Respectfully submitted,



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01 FC:1401 340.00 DA